

P-225 · P-235

Preloaded PICA™ Power High-Load Piezo Actuators (HVPZT) with Sensor Options



High-load piezo actuators P-235.1S, .4S and .9S, P-225.8S and .1S (from left) with CD for size comparison

- **Extremely High Stiffness**
- **Pushing Forces to 30,000 N**
- **Pulling Forces to 3500 N**
- **Travel Ranges to 180 µm**
- **Options: Versions for Vacuum, High- and Low-Temperatures and with Water-Resistant Case**

P-225 and P-235 are preloaded, high-load piezo actuators (translators) for static and dynamic applications. They provide sub-millisecond response and sub-nanometer resolution.

Application Examples

- Precision engineering / micromechanics
- Adaptive mechanics
- Active vibration damping
- Adaptronics
- Static and dynamic precision positioning
- Force generation / materials testing

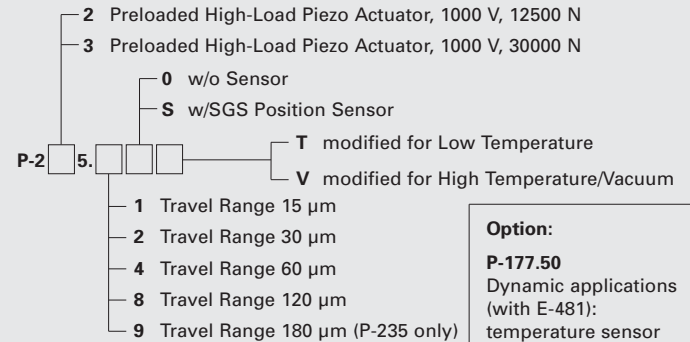
These ultra-high-force linear actuators consist of PICA™ Power piezoelectric ceramic-stacks encapsulated in a stainless steel case with stainless steel end pieces and a frictionless internal spring preload. The high load capacity and preload makes them ideal for machining applications and active vibration cancellation.

High Displacement with Ultra-High Reliability

PICA™ Power actuators are optimized for high-temperature working conditions and high-duty-cycle dynamic applications.

All PICA™ piezo ceramics are specifically designed for high-duty-cycle applications. With PI's extensive applications knowledge, gained over sever-

Ordering Information



Please read "Options and Accessories", page 1-44 ff, for further information.

Extensions cables, adapters & connectors: see in "Accessories" in the "Piezo Drivers & Nanopositioning Controllers" section.

Option:

P-177.50
 Dynamic applications (with E-481): temperature sensor and protective air for PICA™ HVPZT

P-706.00
 Water-resistant case

al decades, performance does not come at the price of reliability. All materials used are specifically matched for robustness and lifetime. Endurance tests on PICA™ actuators prove consistent performance, even after billions (1,000,000,000) of cycles.

Open- and Closed-Loop Models for Optimum Dynamics and Linearity

The standard models are ideal for open loop positioning applications. In this mode the actuator displacement is roughly proportional to the applied voltage.

Open-loop operation is ideal for applications where the fastest response and the highest bandwidth are essential. Here, commanding and reading the target position in absolute values is either not important or carried out by an external feedback loop.

For highest positioning accuracy and repeatability, select the factory installed closed-loop option with integrated ultra-high-resolution strain gauge position sensors and operate with PI servo-control electronics. For more information, read

the "Tutorial: Piezoelectrics in Nanopositioning".

High Flexibility with PI Amplifiers, Drivers & Controllers

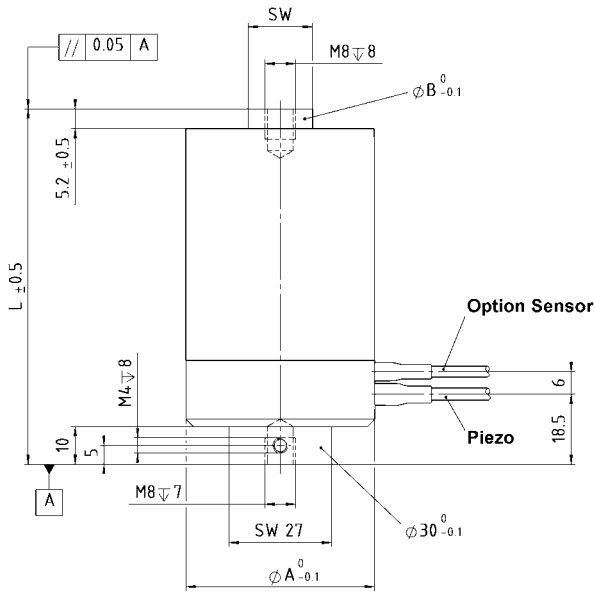
PI offers a wide range of control electronics for piezo actuators from economical, low-power piezo drivers to the E-481 high-performance amplifier / controller providing 2000 W of dynamic power.

For closed-loop operation a wide variety of analog and digital controllers is available. The E-500 modular system can be easily upgraded from an amplifier to a servo controller, including different interface / display modules.

Read details in Mounting and Handling Guidelines page 1-48.

Notes

High-resolution amplifiers and servo-control electronics, both digital and analog, see selection guide in the "Piezo Drivers & Nanopositioning Controllers" section page 6-2 ff.



	L [mm]	∅A [mm]	∅B [mm]	SW
P-225.1x	55	39.8	16	13
P-225.2x	68	39.8	16	13
P-225.4x	94	39.8	16	13
P-225.8x	147	39.8	16	13
P-235.1x	55	49.8	20	17
P-235.2x	68	49.8	20	17
P-235.4x	94	49.8	20	17
P-235.8x	147	49.8	20	17
P-235.9x	199	49.8	20	17

P-225 and P-235, dimensions in mm. End pieces and case of stainless steel.
 Sensor connection: LEMO FFA.0S.304; 1 m coaxial cable with PUR insulation.
 Voltage connection: LEMO FGG.0B.701.CJA.1173, 1 m cable with PUR insulation,
 2-conductor, shielded

Piezoaktoren

Piezo-Nano-positioniersysteme

Aktive Optik /
Piezokippspiegel

Tutorium: Nanopositionieren mit Piezos

Kapazitive Sensoren

Piezoelektronik

Hexapoden /
Mikropositionierung

Faserpositionierung

Motorsteuerungen

Piezomotoren /
Stelltische

Index

Technische Daten

	P-225.10	P-225.20	P-225.40	P-225.80	P-235.10	P-235.20	P-235.40	P-235.80	P-235.90	Unit	Tolerance
Operating voltage	0 to 1000	0 to 1000	0 to 1000	0 to 1000	0 to 1000	0 to 1000	0 to 1000	0 to 1000	0 to 1000	V	
Motion and positioning											
Closed-loop travel	15	30	60	120	15	30	60	120	180	µm	
Open-loop resolution**	0,3	0,6	1,2	2,4	0,3	0,6	1,2	2,4	3,6	nm	typ.
Closed-loop resolution****	0,15	0,3	0,6	1,2	0,15	0,3	0,6	1,2	1,8	nm	typ.
Linearity	0,2	0,2	0,2	0,2	0,2	0,2	0,2	0,2	0,2	%	typ.
Mechanical properties											
Static large-signal stiffness***	480	330	200	110	860	600	380	210	150	N/µm	±20
Unloaded resonant frequency	14	10	7	4	14	10	7	3,9	2,8	kHz	±20 %
Push/pull force capacity	12500 / 2000	12500 / 2000	12500 / 2000	12500 / 2000	30000 / 3500	30000 / 3500	30000 / 3500	30000 / 3500	30000 / 3500	N	Max.
Shear force limit	255	152	84	73	707	420	232	147	147	N	
Torque limit (on tip)	1,5	1,5	1,5	1,5	2	2	2	2	2	Nm	
Drive properties											
El. capacitance	320	630	1300	2600	550	1100	2400	5100	7800	nF	±20 %
Dynamic operating current coefficient	33	33	33	33	65	65	65	65	65	µA/(Hz x µm)	±20 %
Miscellaneous											
Mass (with cable)	410	470	610	900	580	690	940	1400	1900	g	±5 %

* Requires SGS sensor. SGS versions are shipped with performance reports

** Measured with an interferometer. The resolution of piezo actuators is not limited by stiction or friction

*** Dynamic small-signal stiffness is ~50 % higher

Piezo ceramic type: PICA™ Power

Operating temperature range: -40 to +80 °C

Recommended controller/driver: B, I, J, see page 6-11

For maximum lifetime, voltages in excess of 750 V should be applied only for short durations

See Notes (Technical Data) for further information see page 2-84 ff